

# Simulation of Propagation of Coherent and Partially-Coherent Photon Beams Across Beamlines



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"Round Beams" Mini-Workshop  
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# Outline

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- SR Calculation Basics
- Wavefront Propagation Calculation using Fourier Optics and Compatible Methods
- Examples of Partially-Coherent SR Emission and Propagation Calculations for Beamlines in Low-Emittance Storage Rings
- Estimating Advantages of Round Beams by Simulations
- Conclusions

# Emission by a Relativistic Charged Particle in Free Space: Retarded Potentials Approach

$$\mathbf{A} = e \int_{-\infty}^{+\infty} \boldsymbol{\beta}_e R^{-1} \delta(\tau - t + R/c) d\tau, \quad \varphi = e \int_{-\infty}^{+\infty} R^{-1} \delta(\tau - t + R/c) d\tau \quad (\text{Gaussian CGS})$$

$$\Downarrow \quad \delta(t') = (1/2\pi) \int_{-\infty}^{+\infty} \exp(i\omega t') d\omega$$

$$\mathbf{A} = \frac{e}{2\pi} \int_{-\infty}^{+\infty} \exp(-i\omega t) d\omega \int_{-\infty}^{+\infty} \boldsymbol{\beta}_e R^{-1} \exp[i\omega(\tau + R/c)] d\tau$$

$$\varphi = \frac{e}{2\pi} \int_{-\infty}^{+\infty} \exp(-i\omega t) d\omega \int_{-\infty}^{+\infty} R^{-1} \exp[i\omega(\tau + R/c)] d\tau$$

Ternov used this approach to derive far-field SR expressions

$$\mathbf{E} = -\frac{1}{c} \frac{\partial \mathbf{A}}{\partial t} - \nabla \varphi = \frac{ie}{2\pi c} \int_{-\infty}^{+\infty} \omega \cdot \exp(-i\omega t) d\omega \int_{-\infty}^{+\infty} [\boldsymbol{\beta}_e - [1 + ic/(\omega R)] \cdot \mathbf{n}] R^{-1} \exp[i\omega(\tau + R/c)] d\tau$$

$$\Downarrow \quad \mathbf{E}_\omega \equiv \int_{-\infty}^{+\infty} \mathbf{E} \exp(i\omega t) dt$$

Exact expression, valid in the Near Field:

$$\mathbf{E}_\omega = iec^{-1} \omega \int_{-\infty}^{+\infty} [\boldsymbol{\beta}_e - [1 + ic/(\omega R)] \cdot \mathbf{n}] R^{-1} \exp[i\omega(\tau + R/c)] d\tau \quad (\checkmark)$$

The equivalence of ( $\checkmark$ ) to the well-known expression of Jackson can be shown by integration by parts

$$\mathbf{E}_\omega = ec^{-1} \int_{-\infty}^{+\infty} \frac{\mathbf{n} \times [(\mathbf{n} - \boldsymbol{\beta}_e) \times \boldsymbol{\beta}'_e] + cR^{-1} \gamma^{-2} (\mathbf{n} - \boldsymbol{\beta}_e)}{R \cdot (1 - \mathbf{n} \cdot \boldsymbol{\beta}_e)^2} \cdot \exp[i\omega(\tau + R/c)] d\tau$$

# Emission by a Relativistic Charged Particle Efficient Computation

Exact expression obtained from Retarded Potentials:

$$\mathbf{E}_\omega = iec^{-1}\omega \int_{-\infty}^{+\infty} [\boldsymbol{\beta}_e - [1 + ic/(\omega R)] \cdot \mathbf{n}] R^{-1} \exp[i\omega(\tau + R/c)] d\tau$$

Phase expansion valid in the Near Field:

$$\omega \cdot (\tau + R/c) \approx \Phi_0 + \frac{\pi}{\lambda} \left[ s\gamma^{-2} + \int_0^s |\boldsymbol{\beta}_{e\perp}|^2 d\tilde{s} + \frac{(x - x_e)^2 + (y - y_e)^2}{z - s} \right]$$

Particle dynamics in external magnetic field:

$$\mathbf{r}_e = \mathbf{r}_e(s, \mathbf{r}_{e0}, \boldsymbol{\beta}_{e0}); \quad \boldsymbol{\beta}_e \approx d\mathbf{r}_e/ds$$

Asymptotic expansion of the radiation integral (to accelerate computation):

$$\int_{-\infty}^{+\infty} F \exp(i\Phi) ds = \int_{s_1}^{s_2} F \exp(i\Phi) ds + \int_{-\infty}^{s_1} F \exp(i\Phi) ds + \int_{s_2}^{+\infty} F \exp(i\Phi) ds$$

$$\int_{-\infty}^{s_1} F \exp(i\Phi) ds + \int_{s_2}^{+\infty} F \exp(i\Phi) ds \approx \left[ \left( \frac{F}{i\Phi'} + \frac{F'\Phi' - F\Phi''}{\Phi'^3} + \dots \right) \exp(i\Phi) \right]_{s_2}^{s_1}$$

# Temporally-Incoherent and Coherent Spontaneous Emission by Many Electrons

Electron Dynamics:

$$\begin{pmatrix} x_e \\ y_e \\ z_e \\ \beta_{xe} \\ \beta_{ye} \\ \delta\gamma_e \end{pmatrix} = \mathbf{A}(\tau) \begin{pmatrix} x_{e0} \\ y_{e0} \\ z_{e0} \\ x'_{e0} \\ y'_{e0} \\ \delta\gamma_{e0} \end{pmatrix} + \mathbf{B}(\tau) \quad \leftarrow \text{Initial Conditions}$$

Spectral Photon Flux per unit Surface emitted by the whole Electron Beam:

$$\frac{dN_{ph}}{dtdS(d\omega/\omega)} = \frac{c^2 \alpha I}{4\pi^2 e^3} \langle |\mathbf{E}_\omega|^2 \rangle$$

"Incoherent" SR

$$\langle |\mathbf{E}_\omega|^2 \rangle = \int |\mathbf{E}_{\omega 0}(\mathbf{r}; x_{e0}, y_{e0}, z_{e0}, x'_{e0}, y'_{e0}, \delta\gamma_{e0})|^2 f(x_{e0}, y_{e0}, z_{e0}, x'_{e0}, y'_{e0}, \delta\gamma_{e0}) dx_{e0} dy_{e0} dz_{e0} dx'_{e0} dy'_{e0} d\delta\gamma_{e0} + (N_e - 1) \left| \int \mathbf{E}_{\omega 0}(\mathbf{r}; x_{e0}, y_{e0}, z_{e0}, x'_{e0}, y'_{e0}, \delta\gamma_{e0}) f(x_{e0}, y_{e0}, z_{e0}, x'_{e0}, y'_{e0}, \delta\gamma_{e0}) dx_{e0} dy_{e0} dz_{e0} dx'_{e0} dy'_{e0} d\delta\gamma_{e0} \right|^2$$

Coherent SR

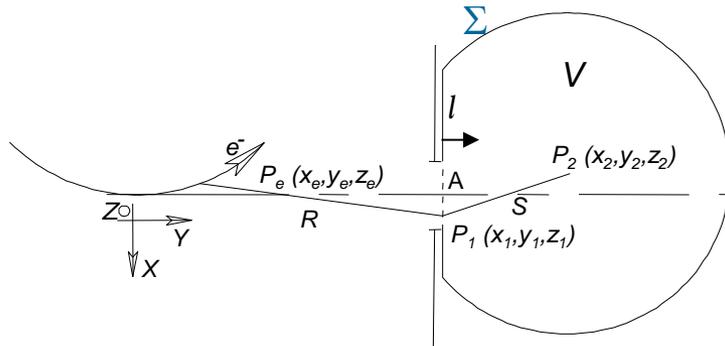
Common Approximation for CSR: "Thin" Electron Beam:  $\langle |\mathbf{E}_\omega|^2 \rangle_{CSR} \approx N_e \left| \int_{-\infty}^{\infty} \tilde{f}(z_{e0}) \exp(ikz_{e0}) dz_{e0} \right|^2 |\mathbf{E}_{\omega 1}|^2$

For Gaussian Longitudinal Bunch Profile:  $\langle |\mathbf{E}_\omega|^2 \rangle_{CSR} \approx N_e \exp(-k^2 \sigma_b^2) |\mathbf{E}_{\omega 1}|^2$

If  $f(x_{e0}, y_{e0}, z_{e0}, x'_{e0}, y'_{e0}, \delta\gamma_{e0})$  is Gaussian, 6-fold integration over electron phase space can be done analytically for the (Mutual) Intensity of Incoherent SR and for the Electric Field of CSR

# Wavefront Propagation in the Case of Full Transverse Coherence

## Kirchhoff Integral Theorem applied to Spontaneous Emission by One Electron



$$\mathbf{E}_{\omega 2\perp}(P_2) \approx \frac{k^2 e}{4\pi} \int_{-\infty}^{+\infty} d\tau \iint_{\Sigma} \frac{\boldsymbol{\beta}_{e\perp} - \mathbf{n}_{\perp}}{RS} \exp[ik(c\tau + R + S)] \cdot (\mathbf{l} \cdot \mathbf{n}_{P_e P_1} + \mathbf{l} \cdot \mathbf{n}_{P_1 P_2}) d\Sigma$$

Valid at large observation angles;

Is applicable to complicated cases of diffraction inside vacuum chamber

## Huygens-Fresnel Principle

$$\mathbf{E}_{\omega 2\perp}(P_2) \approx \frac{k}{4\pi i} \iint_A \mathbf{E}_{\omega 1\perp}(P_1) \frac{\exp(ikS)}{S} (\mathbf{l} \cdot \tilde{\mathbf{n}} + \mathbf{l} \cdot \mathbf{n}_{P_1 P_2}) d\Sigma$$

## Fourier Optics

**Free Space:**  
(between parallel planes  
perpendicular to optical axis)

$$\mathbf{E}_{\omega 2\perp}(x_2, y_2) \approx \frac{k}{2\pi i L} \iint \mathbf{E}_{\omega 1\perp}(x_1, y_1) \exp[ik[L^2 + (x_2 - x_1)^2 + (y_2 - y_1)^2]^{1/2}] dx_1 dy_1$$

Assumption of small angles

**"Thin" Optical Element:**

$$\mathbf{E}_{\omega 2\perp}(x, y) \approx \mathbf{T}(x, y, \omega) \mathbf{E}_{\omega 1\perp}(x, y)$$

**"Thick" Optical Element:**  
(propagation from transverse  
plane before the element to a  
transverse plane just after it)

$$\mathbf{E}_{\omega 2\perp}(x_2, y_2) \approx \mathbf{G}(x_2, y_2, \omega) \exp[ik\Lambda(x_2, y_2, k)] \mathbf{E}_{\omega 1\perp}(x_1(x_2, y_2), y_1(x_2, y_2))$$

# "Economic" and Numerically Stable Version of the Free-Space Fourier-Optics Propagator

## Huygens-Fresnel Principle:

(paraxial approximation)

$$\mathbf{E}_{\omega 2\perp}(x_2, y_2) \approx \frac{k}{2\pi i L} \iint \mathbf{E}_{\omega 1\perp}(x_1, y_1) \exp[ik[L^2 + (x_2 - x_1)^2 + (y_2 - y_1)^2]^{1/2}] dx_1 dy_1$$

## Analytical Treatment of Quadratic Phase Term:

Before Propagation:

$$\mathbf{E}_{\omega 1\perp}(x_1, y_1) = \mathbf{F}_{\omega 1}(x_1, y_1) \exp\left[ ik \frac{(x_1 - x_0)^2}{2R_x} + ik \frac{(y_1 - y_0)^2}{2R_y} \right]$$

After Propagation:

$$\mathbf{E}_{\omega 2\perp}(x_2, y_2) \approx \frac{k}{2\pi i L} \exp(ikL) \iint_{\Sigma} \mathbf{F}_{\omega 1}(x_1, y_1) \exp\left[ ik \frac{(x_1 - x_0)^2}{2R_x} + ik \frac{(y_1 - y_0)^2}{2R_y} + ik \frac{(x_2 - x_1)^2 + (y_2 - y_1)^2}{2L} \right] dx_1 dy_1$$

$$= \frac{k}{2\pi i L} \exp\left[ ikL + ik \frac{(x_2 - x_0)^2}{2(R_x + L)} + ik \frac{(y_2 - y_0)^2}{2(R_y + L)} \right] \times$$

$$\times \iint_{\Sigma} \mathbf{F}_{\omega 1}(x_1, y_1) \exp\left[ ik \frac{R_x + L}{2R_x L} \left( x_1 - \frac{R_x x_2 + Lx_0}{R_x + L} \right)^2 + ik \frac{R_y + L}{2R_y L} \left( y_1 - \frac{R_y y_2 + Ly_0}{R_y + L} \right)^2 \right] dx_1 dy_1$$

$$= \mathbf{F}_{\omega 2}(x_2, y_2) \exp\left[ ik \frac{(x_2 - x_0)^2}{2(R_x + L)} + ik \frac{(y_2 - y_0)^2}{2(R_y + L)} \right]$$

# An Approach to High-Accuracy Partially-Coherent Emission and Wavefront Propagation Simulations

Averaging (over phase-space volume occupied by e-beam) of the intensity (or “mutual” intensity, or mathem. brightness) obtained from electric field emitted by an electron and propagated through an optical system:

$$I_{\omega}(x, y) = \int I_{\omega 1}(x, y; x_e, y_e, z_e, x'_e, y'_e, \delta\gamma_e) f(x_e, y_e, z_e, x'_e, y'_e, \delta\gamma_e) dx_e dy_e dz_e dx'_e dy'_e d\delta\gamma_e$$

$$I_{\omega 1}(x, y; x_e, y_e, z_e, x'_e, y'_e, \delta\gamma_e) = |\mathbf{E}_{\omega 1\perp}(x, y; x_e, y_e, z_e, x'_e, y'_e, \delta\gamma_e)|^2$$

$$M_{\omega 1}(x, y, \tilde{x}, \tilde{y}; x_e, y_e, z_e, x'_e, y'_e, \delta\gamma_e) = \mathbf{E}_{\omega 1\perp}(x, y; x_e, y_e, z_e, x'_e, y'_e, \delta\gamma_e) \mathbf{E}_{\omega 1\perp}^*(\tilde{x}, \tilde{y}; x_e, y_e, z_e, x'_e, y'_e, \delta\gamma_e)$$

$$B_{\omega 1}(x, y, \theta_x, \theta_y; x_e, y_e, z_e, x'_e, y'_e, \delta\gamma_e) \sim \mathbf{E}_{\omega 1\perp}(x, y; x_e, y_e, z_e, x'_e, y'_e, \delta\gamma_e) \int \mathbf{E}_{\omega 1\perp}^*(\tilde{x}, \tilde{y}; x_e, y_e, z_e, x'_e, y'_e, \delta\gamma_e) \exp\left[i\frac{\omega}{c}(\theta_x \tilde{x} + \theta_y \tilde{y})\right] d\tilde{x} d\tilde{y}$$

This method is **general and accurate**. For the most part, it is already implemented in SRW code. However, it can be **CPU-intensive**, requiring **parallel calculations** on a multi-core server or a small cluster. Several approaches are considered for increasing the efficiency, including use of low-discrepancy sequences (collaboration with R. Lindberg, K.-J. Kim, X. Shi, ANL), “improved Monte-Carlo” type techniques, as well as “coherent mode decomposition”.

**NOTE:** the **smaller the e-beam emittance** (the higher the radiation coherence) – the **faster is the convergence** of simulations with this general method.

**NOTE:** **convolution** can be valid in some cases, such as pure projection geometry, focusing by a thin lens, diffraction at one slit, etc.

$$I_{\omega}(x, y) \approx \int \tilde{I}_{\omega 1}(x - \tilde{x}_e, y - \tilde{y}_e) \tilde{f}(\tilde{x}_e, \tilde{y}_e) d\tilde{x}_e d\tilde{y}_e$$

If convolution is valid, the **calculations can be accelerated dramatically**. The validity of the convolution relation can be easily verified numerically.

# "Synchrotron Radiation Workshop" – Physical Optics Code for SR Emission and Propagation Calculations

First work on Wavefront Propagation applied to SR beamlines (PHASE code):

**J. Bahrtdt, *Appl. Opt.* 36 (19) 4367 (1997)**

- First official version of SRW was developed at ESRF in 1997-98 (written in C++, interfaced to IGOR Pro); compiled versions are distributed from:  
<http://www.esrf.eu/Accelerators/Groups/InsertionDevices/Software/SRW>
- SRW was released to Open Source in 2012 under BSD type license.



The main Open Source repository, containing all C/C++ sources, C API, all interfaces and project development files, is on GitHub:

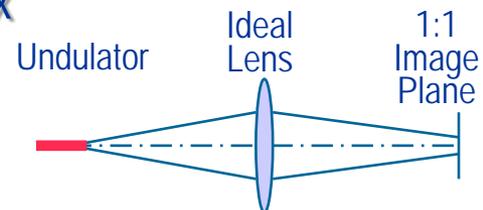
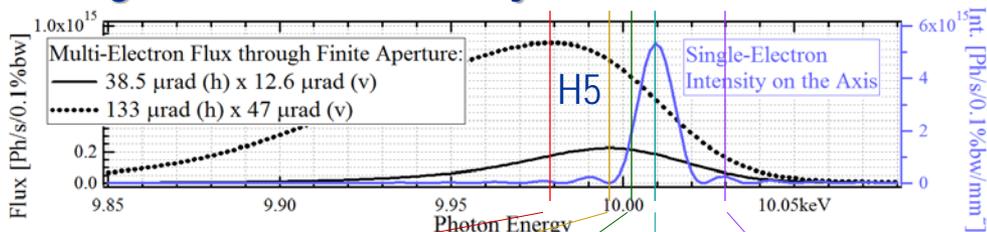
<https://github.com/ochubar/SRW>

- SRW for Python (2.7.x and 3.x, 32- and 64-bit) cross-platform versions were released in 2012
- SRW development is partially supported by US DOE SBIR Program (BNL acts as subcontractor of RadiaSoft LLC, headed by D. Bruhwiler) 
- SRW under Sirepo web interface is available since 2015:  
<https://beta.sirepo.com/light#/home>

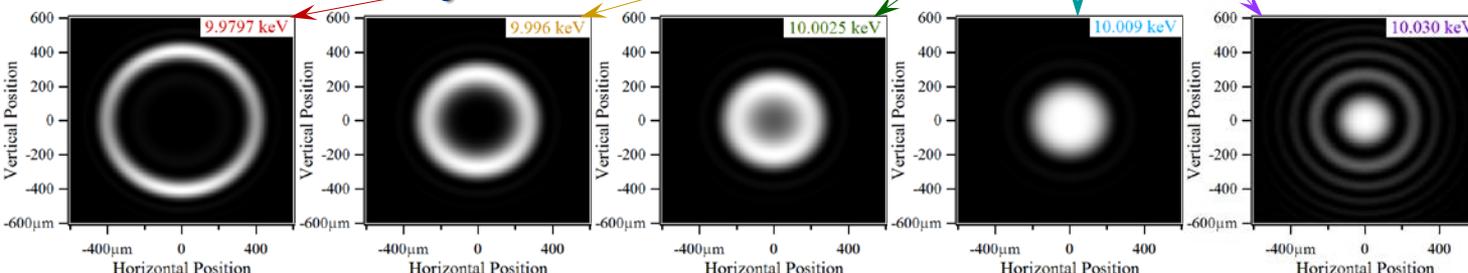
# Single-Electron (Fully Transversely-Coherent) UR Intensity Distributions, "in Far Field" and "at Source"

## UR "Single-Electron" Intensity and "Multi-Electron" Flux

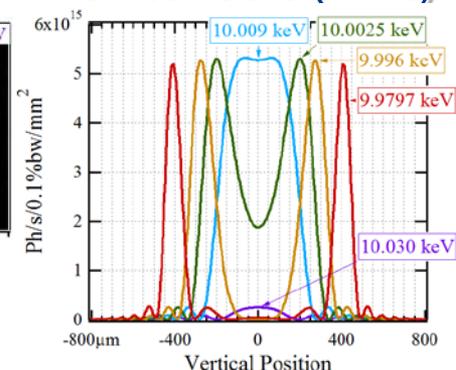
E-Beam Energy: 3 GeV  
 Current: 0.5 A  
 Undulator Period: 20 mm



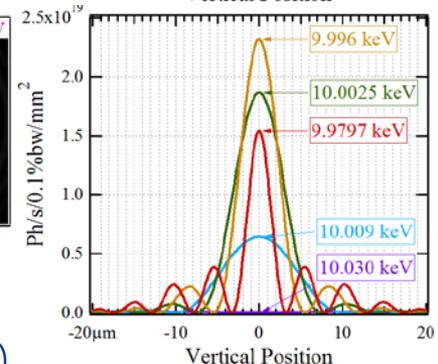
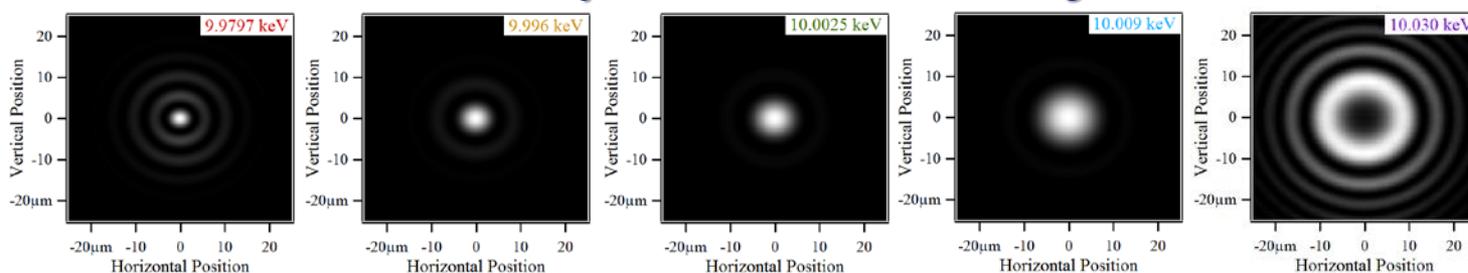
## Intensity Distributions at 30 m from Undulator Center



## Vertical Cuts (x = 0)



## Intensity Distributions in 1:1 Image Plane



## "Phase-Space Volume" Estimation for Vertical Plane

(RMS sizes/divergences calculated for the portions of intensity distributions containing 95% of flux)

$$\sigma_y \sigma_y' \approx 7.7 \frac{\lambda}{4\pi}$$

$$3.3 \frac{\lambda}{4\pi}$$

$$1.9 \frac{\lambda}{4\pi}$$

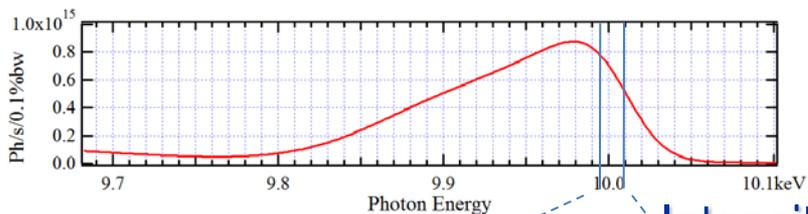
$$1.5 \frac{\lambda}{4\pi}$$

$$9.2 \frac{\lambda}{4\pi}$$

# Calculated UR Intensity Distributions from Finite-Emittance Electron Beam, "in Far Field" and "at Source"

## IVU20-3m Spectral Flux

through 100  $\mu\text{rad}$  (H) x 50  $\mu\text{rad}$  (V) Aperture  
at K~1.5 providing H5 peak at ~10 keV



Electron Beam (NSLS-II):

Hor. Emittance: 0.9 nm  
Vert. Emittance: 8 pm  
Energy Spread:  $8.9 \times 10^{-4}$   
Current: 0.5 A  
Low-Beta Straight

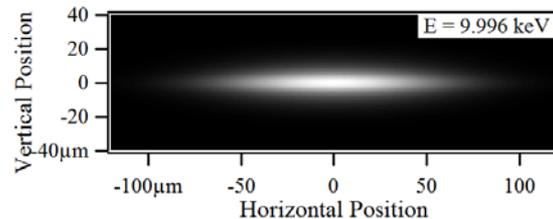
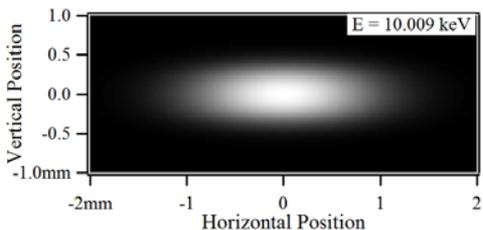
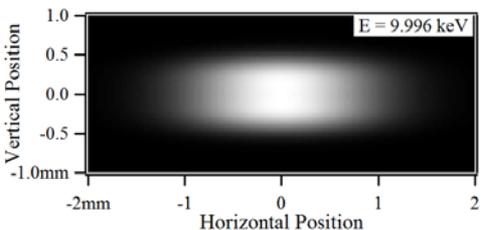
## Test Optical Scheme



## Intensity Distributions at ~10 keV

At 30-m from Undulator

In 1:1 Image Plane

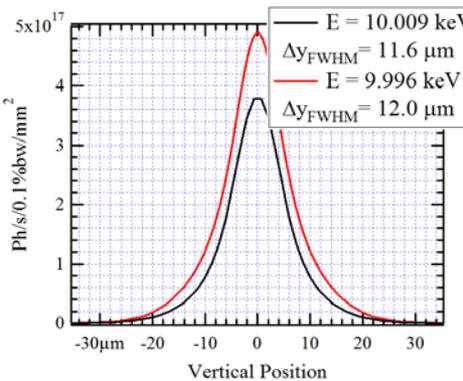
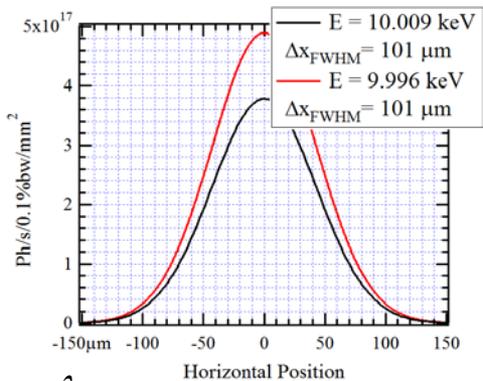
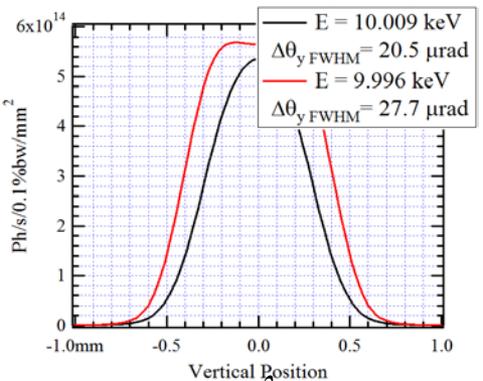
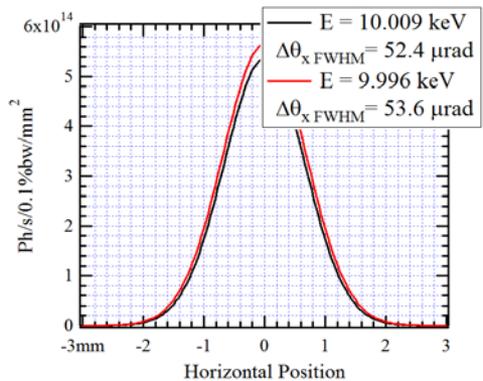


### Horizontal Cuts (y = 0)

### Vertical Cuts (x = 0)

### Horizontal Cuts (y = 0)

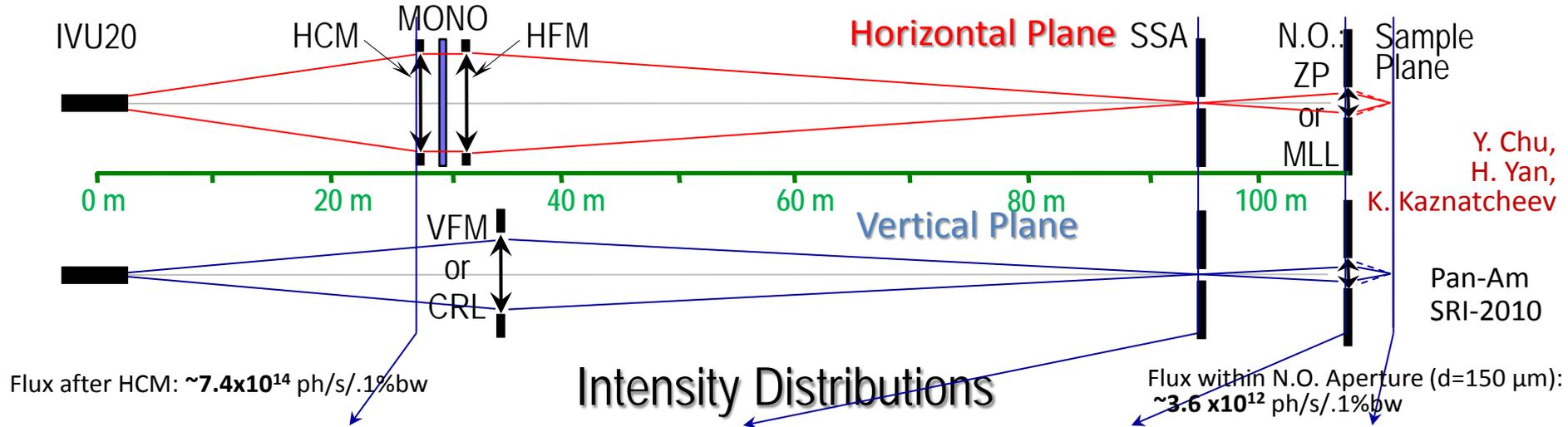
### Vertical Cuts (x = 0)



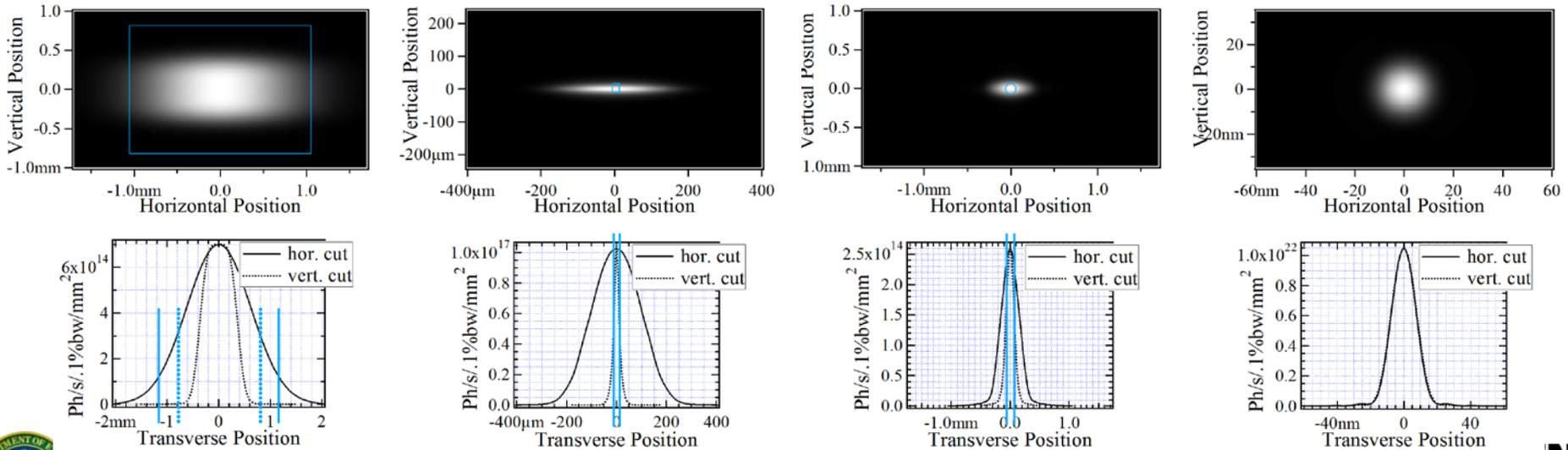
$$\sigma_x \sigma_x' \approx 97 \frac{\lambda}{4\pi}; \quad \sigma_y \sigma_y' \approx 5.7 \frac{\lambda}{4\pi}$$

...very far from Coherent Gaussian Beam !

# NSLS-II Hard X-Ray Nanoprobe (HXN) Beamline Optical Layout and Wavefront Propagation Simulations



## Intensity Distributions



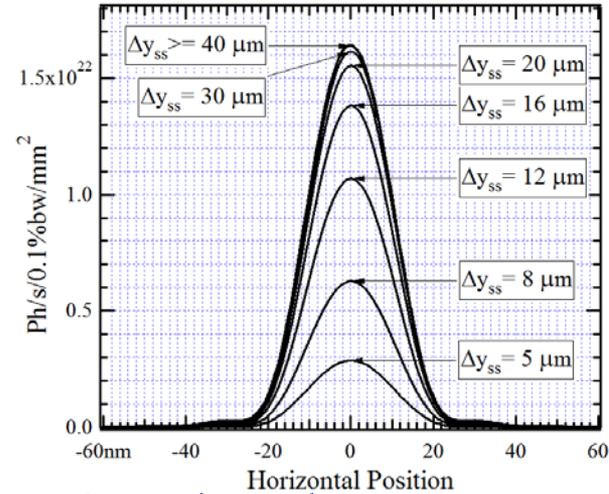
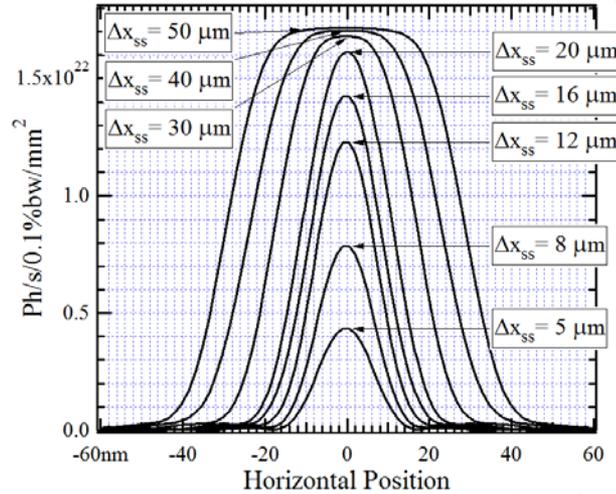
**ENERGY**

# Intensity Distributions at Sample for Different Secondary Source Aperture Sizes at HXN (NSLS-II)

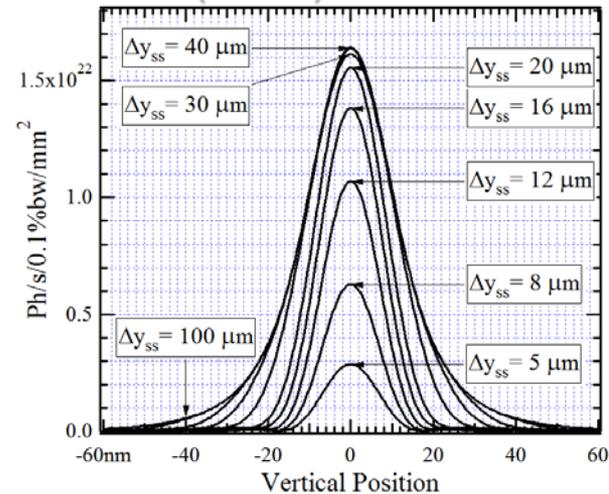
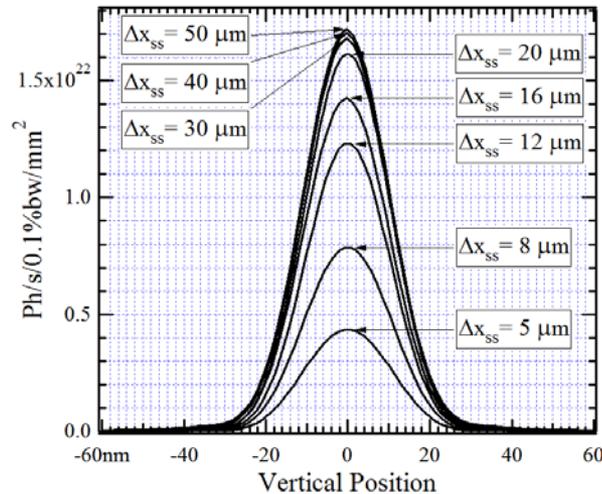
In Horizontal Median Plane ( $y = 0$ )

For Different Horizontal SSA Sizes ( $\Delta x_{ss}$ )

For Different Vertical SSA Sizes ( $\Delta y_{ss}$ )



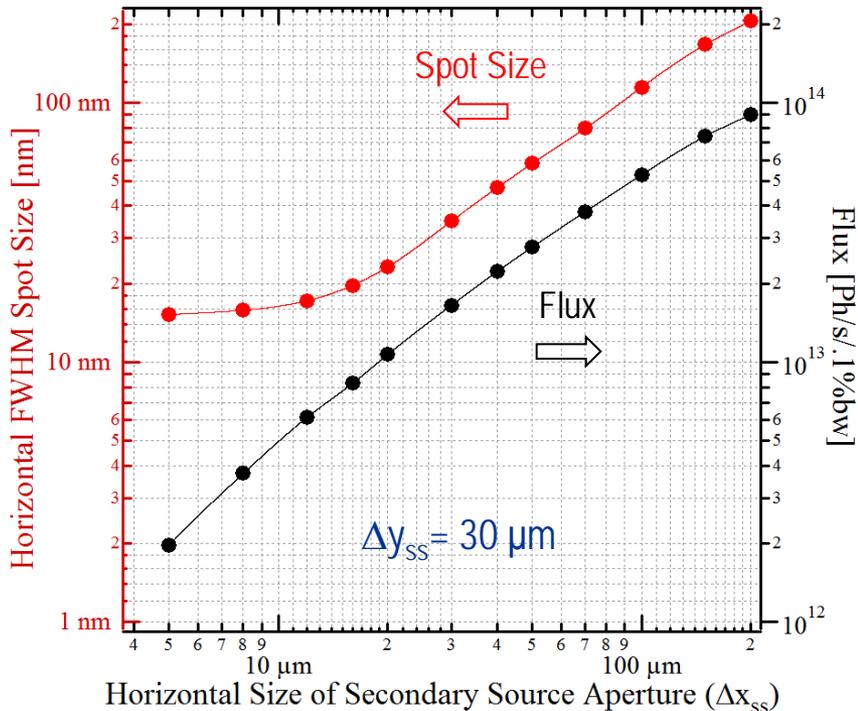
In Vertical Median Plane ( $x = 0$ )



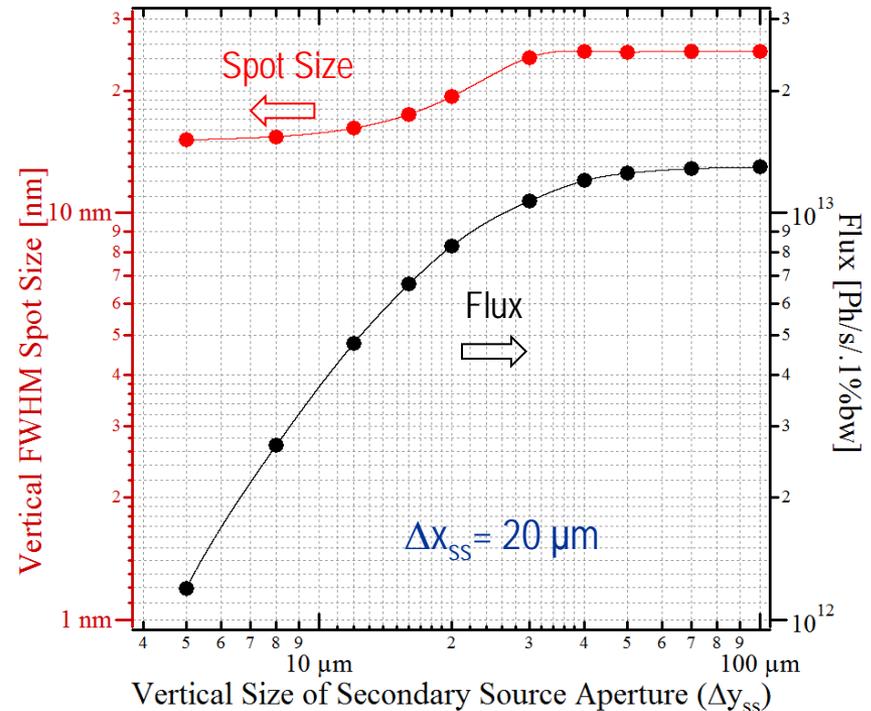
For Nanofocusing Optics with  $F = 18.14 \text{ mm}$ ,  $D = 150 \mu\text{m}$  ( $\Delta r \approx 15 \text{ nm}$ ;  $E_{ph} \approx 10 \text{ keV}$ )  
SSA located at 94 m, Nanofocusing Optics at 109 m from Undulator

# Final Focal Spot Size and Flux vs Secondary Source Aperture Size (HXN, NSLS-II)

## Horizontal Spot Size and Flux vs Horizontal Secondary Source Aperture Size

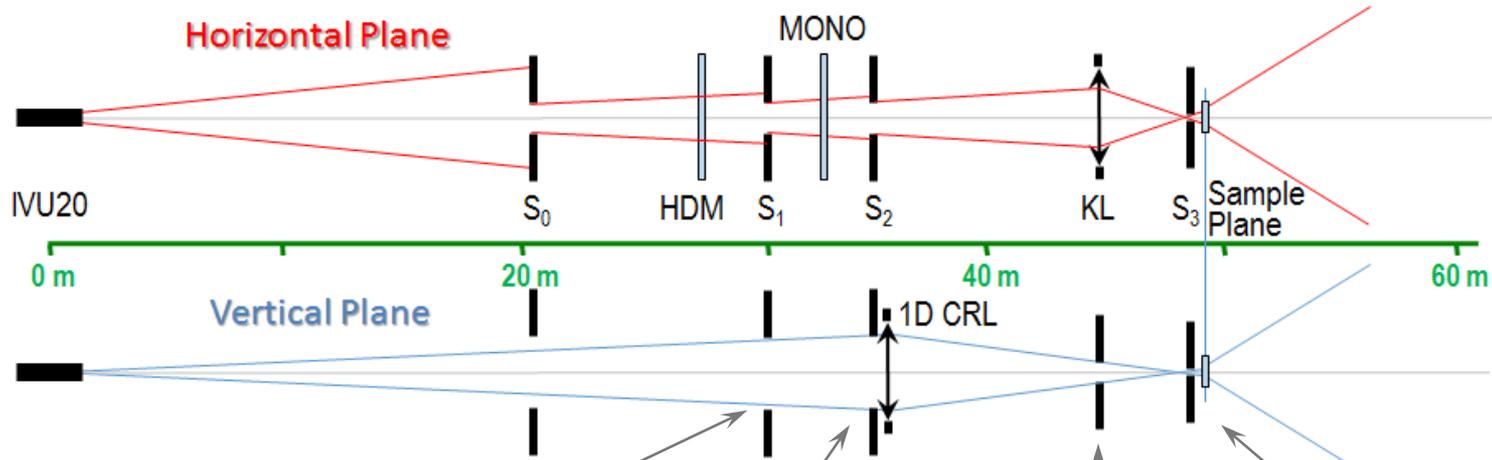


## Vertical Spot Size and Flux vs Vertical Secondary Source Aperture Size



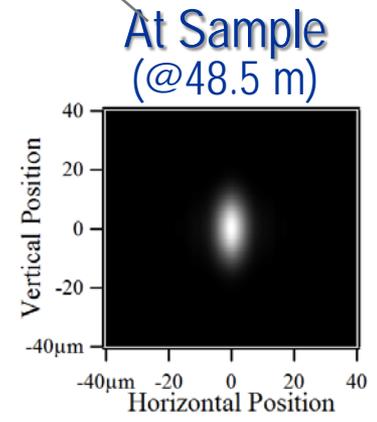
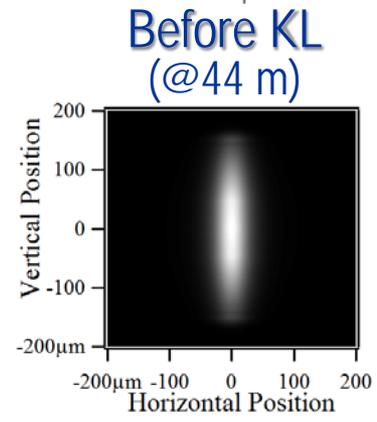
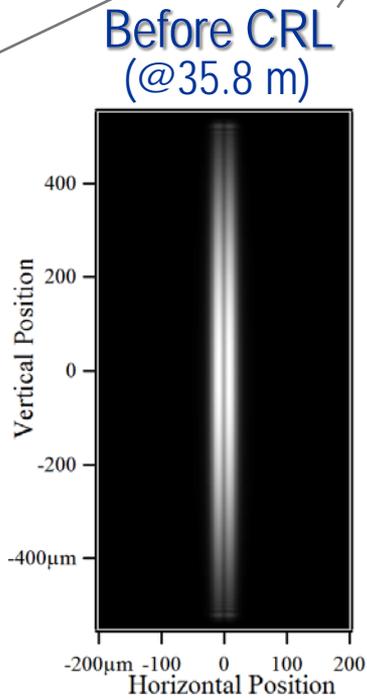
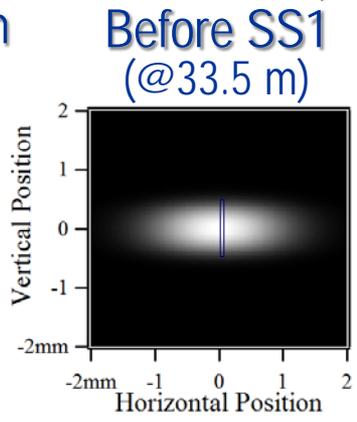
Secondary Source Aperture located at 94 m from Undulator  
 Spot Size and Flux calculated for Nanofocusing Optics simulated by Ideal Lens  
 with  $F = 18.14 \text{ mm}$ ,  $D = 150 \mu\text{m}$  located at 15 m from Secondary Source (109 m from Undulator)

# NSLS-II Coherent Hard X-Ray (CHX) Beamline Optical Layout and Wavefront Propagation Simulations



A. Fluerasu  
L. Wiegart

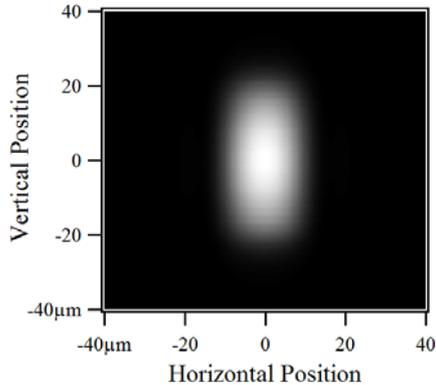
Intensity Distributions  
for  $E = 10$  keV  
 $\Delta S_{1x} = 44 \mu\text{m}$   
 $\Delta S_{1y} = 1 \text{ mm}$



Flux:  $10^{13}$  ph/s/.1%bw

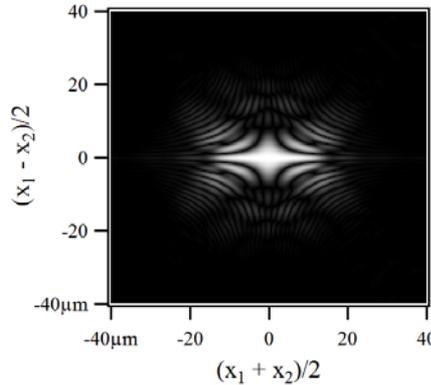
# Tracking Intensity and Degree of Transverse Coherence at Sample (CHX @ NSLS-II)

Intensity Distribution

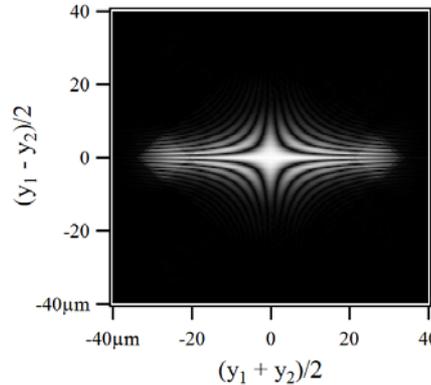


Degree of Transverse Coherence

In Horizontal Mid-Plane



In Vertical Mid-Plane

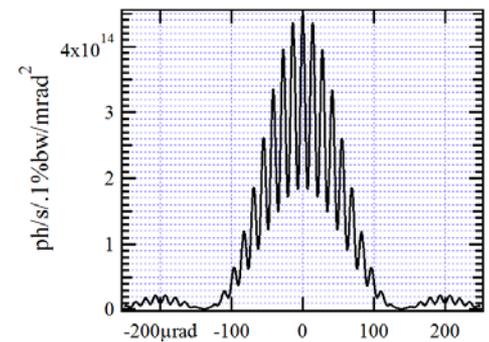


$$\mu(\mathbf{r}_1, \mathbf{r}_2, \omega) = |M(\mathbf{r}_1, \mathbf{r}_2, \omega)| / [M(\mathbf{r}_1, \mathbf{r}_1, \omega)M(\mathbf{r}_2, \mathbf{r}_2, \omega)]^{1/2}$$

$$M(\mathbf{r}_1, \mathbf{r}_2, \omega) \sim \langle \mathbf{E}_\perp(\mathbf{r}_1, \omega) \mathbf{E}_\perp^*(\mathbf{r}_2, \omega) \rangle$$

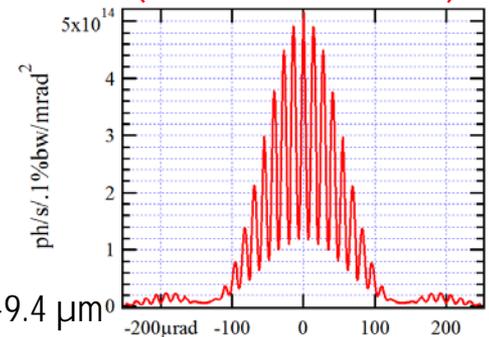
Angular Intensity (far field)  
after Two Slits  
separated by 10  $\mu\text{m}$

In Horizontal Plane  
(after vertical slits)

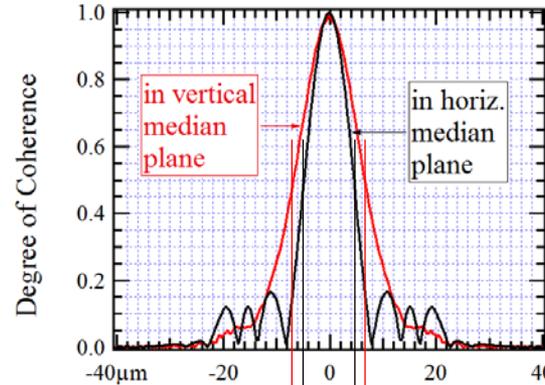
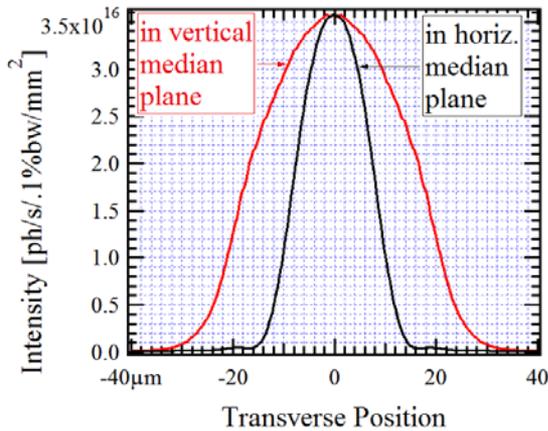


Horizontal Angle

In Vertical Plane  
(after horizontal slits)



Vertical Angle



$(x_1 - x_2)/2$ ,  $(y_1 - y_2)/2$

hor. coherence length:  $\sim 9.4 \mu\text{m}$

vert. coherence length:  $\sim 13.4 \mu\text{m}$



U.S. DEPARTMENT OF  
**ENERGY**

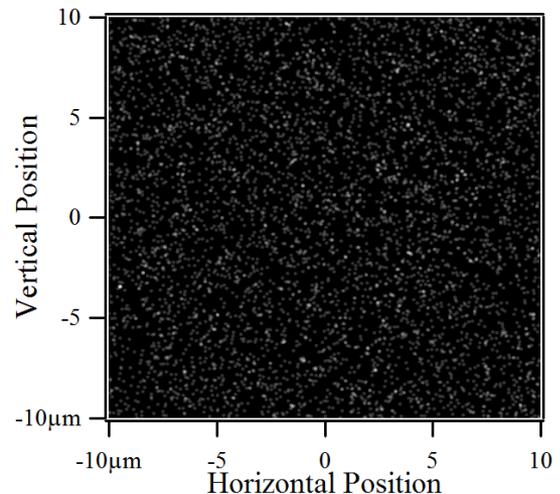
Good agreement with 2-slit interference simulation results

# Towards Simulation of Complete Experiments (CHX @ NSLS-II)

## Diffraction / Scattering from Test Sample

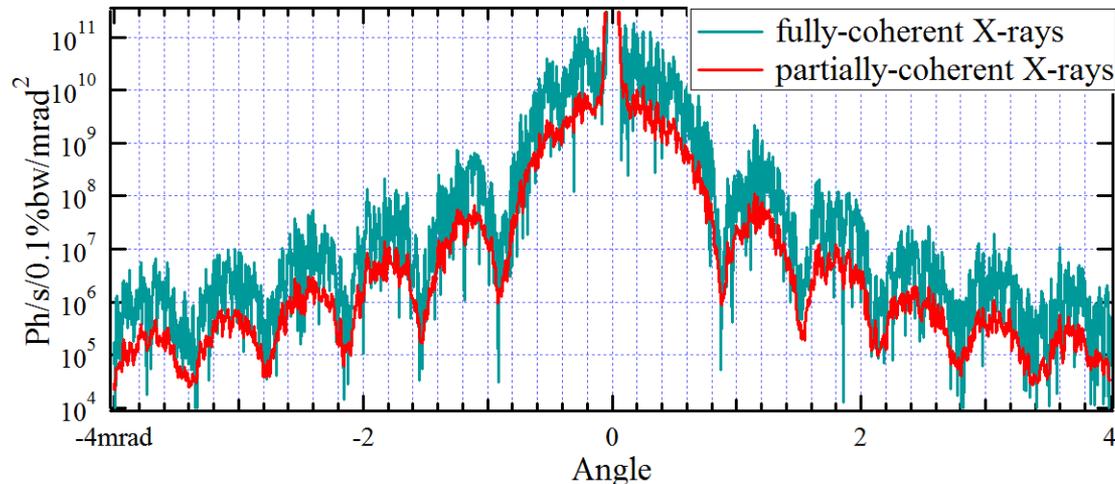
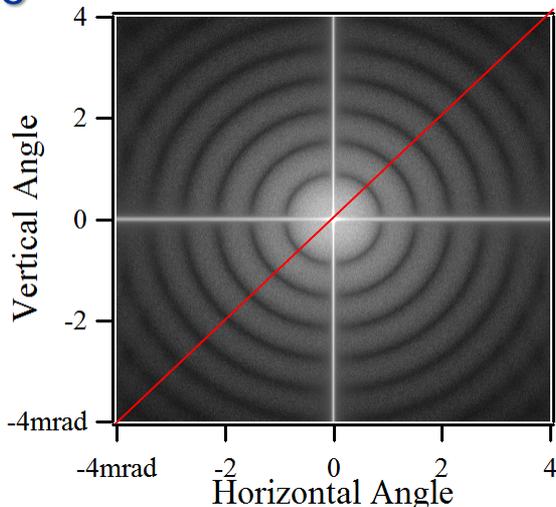
5000 "Silica Spheres",  $d \approx 200$  nm

Partially-coherent simulations allow for identifying best conditions (/ beamline settings) for XPCS and many other types of experiments.



Sample simulation data from A. Fluerașu

Angular distribution of scattered X-rays at  $E=10$  keV,  $\Delta S_{1x} = 44$   $\mu\text{m}$ ,  $\Delta S_{1y} = 1$  mm



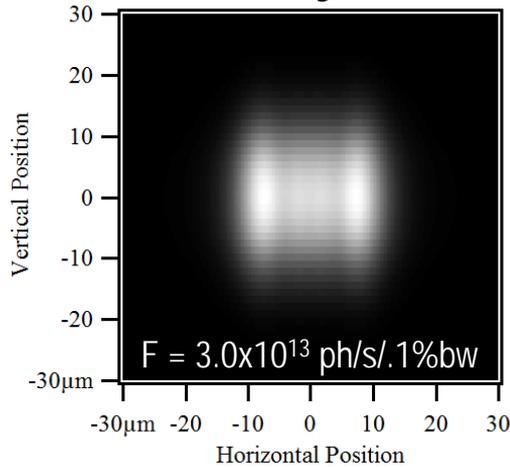
# Attempting to Obtain Equal Horizontal and Vertical Spot Sizes and Coherence Lengths at CHX Sample (I)

Intensity Distributions

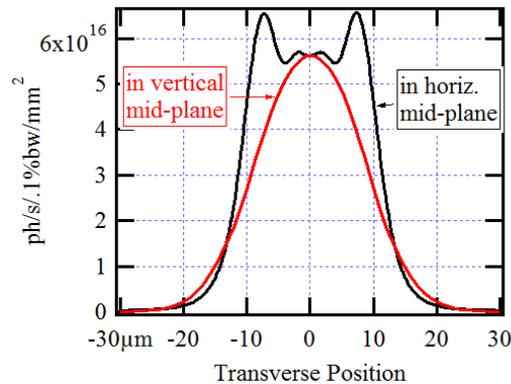
Degree of Transv. Coherence

Cuts vs Horizontal and Vertical Positions

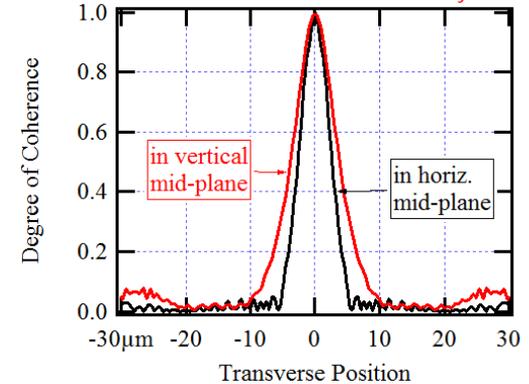
Currently Attainable (at  $\epsilon_x = 0.9$  nm,  $\beta_x = 2$  m,  $\epsilon_y = 8$  pm,  $\beta_y = 1$  m)



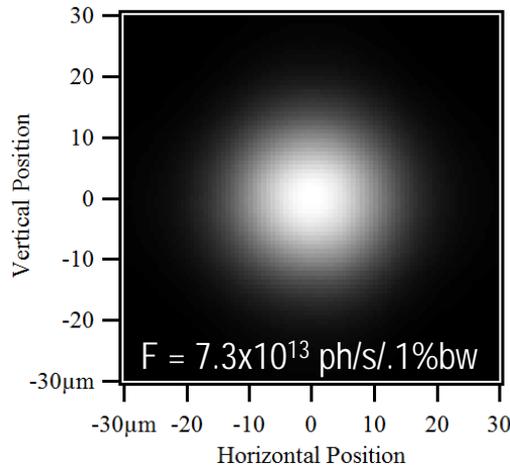
Spot Sizes:  $\Delta x = 22$   $\mu\text{m}$ ,  $\Delta y = 20$   $\mu\text{m}$



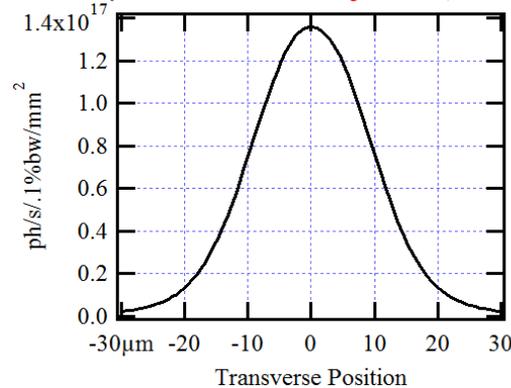
Coherence Lengths:  $l_x = 5.2$   $\mu\text{m}$ ,  $l_y = 7.7$   $\mu\text{m}$



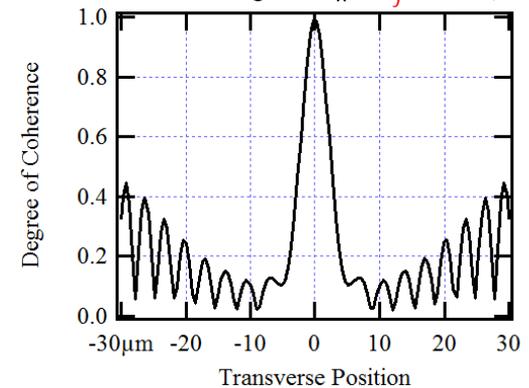
Would be Attainable with a "Round E-Beam" (at  $\epsilon_x = \epsilon_y = 85$  pm,  $\beta_x = \beta_y = 2$  m)



Spot Sizes:  $\Delta x = \Delta y = 22$   $\mu\text{m}$



Coherence Lengths:  $l_x = l_y = 5.1$   $\mu\text{m}$



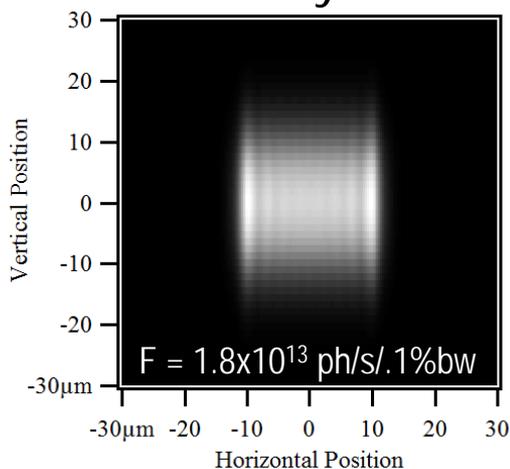
# Attempting to Obtain Equal Horizontal and Vertical Spot Sizes and Coherence Lengths at CHX Sample (II)

Intensity Distributions

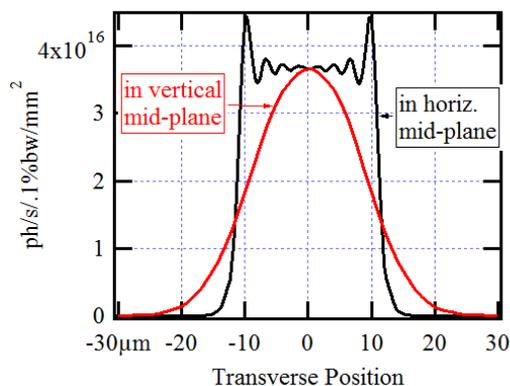
Degree of Transv. Coherence

Cuts vs Horizontal and Vertical Positions

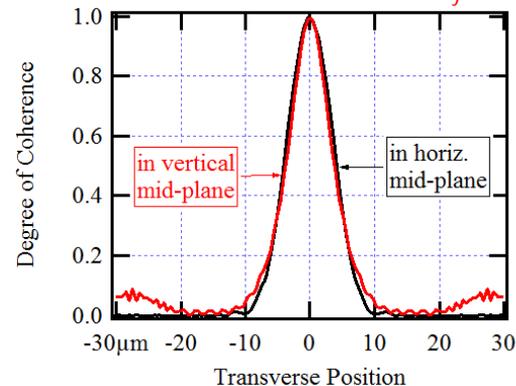
Currently Attainable (at  $\epsilon_x = 0.9$  nm,  $\beta_x = 2$  m,  $\epsilon_y = 8$  pm,  $\beta_y = 1$  m)



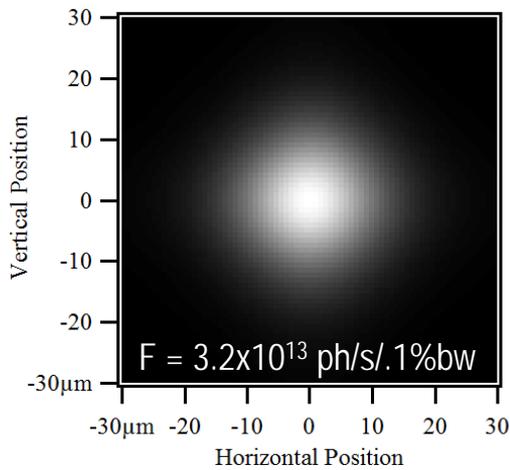
Spot Sizes:  $\Delta x = 22$   $\mu\text{m}$ ,  $\Delta y = 20$   $\mu\text{m}$



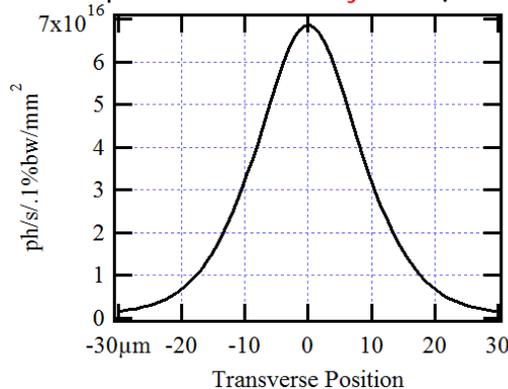
Coherence Lengths:  $l_x = 8.2$   $\mu\text{m}$ ,  $l_y = 7.7$   $\mu\text{m}$



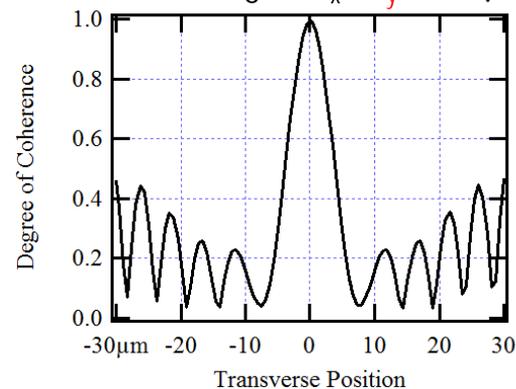
Would be Attainable with a "Round E-Beam" (at  $\epsilon_x = \epsilon_y = 85$  pm,  $\beta_x = \beta_y = 2$  m)



Spot Sizes:  $\Delta x = \Delta y = 19$   $\mu\text{m}$



Coherence Lengths:  $l_x = l_y = 7.8$   $\mu\text{m}$



# Conclusions

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- High accuracy partially-coherent SR emission and propagation calculations for light sources are possible and (more-or-less) feasible with SRW code. Many applications are possible, including simulation of performances of IDs, X-ray optics in beamlines, and in some cases entire user experiments.
- Creating “round” electron beams in new low-emittance storage rings looks attractive for cases when round radiation spots at sample are required. This can result in gain in brightness and coherent flux and facilitates manipulations with / conditioning of X-ray beam. However, “matching” of single-electron UR angular divergences and source sizes with those of e-beam is important. Any particular case can be studied using partially-coherent simulations.

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